

# **SYSTEM AND METHOD FOR INTERLOCKING MANAGEMENT IN SEMICONDUCTOR MATERIAL SUPPLY EQUIPMENT**

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## **ABSTRACT OF THE INVENTION**

10 In the present invention, a system for interlocking material supply equipment in semiconductor manufacture management system comprises collecting means for collecting a user's identification and content identification of material supply equipment. Communication means is for transferring the user's identification and the content identification. A controller is communicated with the material supply  
15 equipment and the collecting means through the communication means. Alarm means is coupled to the material supply equipment and communicated with the controller. A method for interlocking managing change materials of material supply equipment comprises collecting a changed material information in an material supply equipment. The  
20 changed material information is checked by a controller communicated with the material supply equipment. An alarm message is transferred to the material supply equipment from the controller. The corresponding material supply equipment is disabled according to said alarm message.